



IFW 2823
8/17/05

PATENT
Attorney Docket No.: 17620R-002600US
Client Ref. No.: 900035US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

TA-CHUNG WU *et al.*

Application No.: 10/668,454

Filed: September 22, 2003

For: METHOD OF FORMING
BOTTOM OXIDE LAYER IN
TRENCH STRUCTURE

Customer No.: 20350

Confirmation No.: 2352

Examiner: Khiem D. Nguyen

Technology Center/Art Unit: 2823

AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 15, 2005, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.